



Image
AF/1200

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re application of: Trung T. Doan

Serial No.: 09/652,713

Filed: August 31, 2000

For: CHEMICAL DISPENSING SYSTEM FOR
SEMICONDUCTOR WAFER PROCESSING

§
§ Group Art Unit: 1763
§
§ Examiner: Sylvia MacArthur
§
§ Atty. Docket: 93-0421.04
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RESPONSE TO THE OFFICE ACTION DATED NOVEMBER 14, 2003

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate of Mailing (37 C.F.R. § 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to:
Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

12-11-03

Date

Husan Jerome
Signature

Dear Sir:

Applicant herein responds to the Office Action of November 14, 2003.